



Attorney Docket No.: SAM-0465  
Application Serial No.: 10/685,738  
Reply to Advisory Action of: September 1, 2006  
and to final Office Action of: June 20, 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Kyung-soo Kim, *et al.*

Examiner: Chen, Kin Chan

Serial No.: 10/685,738

Group Art Unit: 1765

Filing Date: October 15, 2003

Title: METHOD FOR MANUFACTURING MULTI-THICKNESS GATE  
DIELECTRIC LAYER OF SEMICONDUCTOR DEVICE

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

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K.C.*

*9/20/06*

SECOND AMENDMENT AFTER FINAL

Sir:

The following is in response to the Advisory Action dated September 1, 2006 and the Office Action dated June 20, 2006, and is filed within the shortened statutory period of three months. Please amend the application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 5 of this paper.